

IDS - 05/12/2006

INFORMATION DISCLOSURE CITATION*(Use several sheets if necessary)*

Docket number (Optional)

15689.73

Application Number

09/889,000

Applicant(s)

Shinji Uebayashi, et al.

Filing Date

6/22/2001

Group Art Unit

2616

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
TP	1	2000-175244	6/23/2000	Japan	H04Q7	22	X	
TP	2	2000-092570	3/31/2000	Japan	H04Q7	38	X	
TP	3	09-205673	8/5/1997	Japan	H04Q7	34	X	
TP	4	09-200826	7/31/1997	Japan	H04Q7	22	X	
TP	5	09-116458	5/2/1997	Japan	H04B1	50	X	
TP	6	05-252098	9/28/1993	Japan	H04B7	26	X	

EXAMINER /Tri Phan/

DATE CONSIDERED 06/23/2006

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*Examiner
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

TP

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Official Notice of Rejection; Case No.: DCMH120076; Patent Application No.: 2000-190173

EXAMINER /Tri Phan/

DATE CONSIDERED 06/23/2006

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